



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Daisuke KOMADA et al.**

Group Art Unit: **1756**

Serial No.: **10/058,426**

Examiner: **Nicole M. Barreca**

Filed: **January 30, 2002**

Confirmation No.: **4298**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE
HAVING SILICON CARBIDE FILM**

Attorney Docket Number: **020060**

Customer Number: **38834**

RESPONSE UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Date: April 21, 2005

Sir:

In response to the Office Action dated January 22, 2005, Applicants submit the following remarks, which begin on page 2 of this paper.